



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshi Fukada  
Serial No. : 10/656,263  
Filed : September 8, 2003  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit : 2826  
Examiner : Fazli Erdem

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the action mailed March 22, 2005, applicant elects the invention of Group I (claims 1-16, 33-40, 49-50, and 55-56) drawn to the a semiconductor device. The election is made without traverse.

No fees are believed to be due. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 4/21/05

  
\_\_\_\_\_  
John F. Hayden  
Reg. No. 37,640

Fish & Richardson P.C.  
1425 K Street, N.W.  
11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331